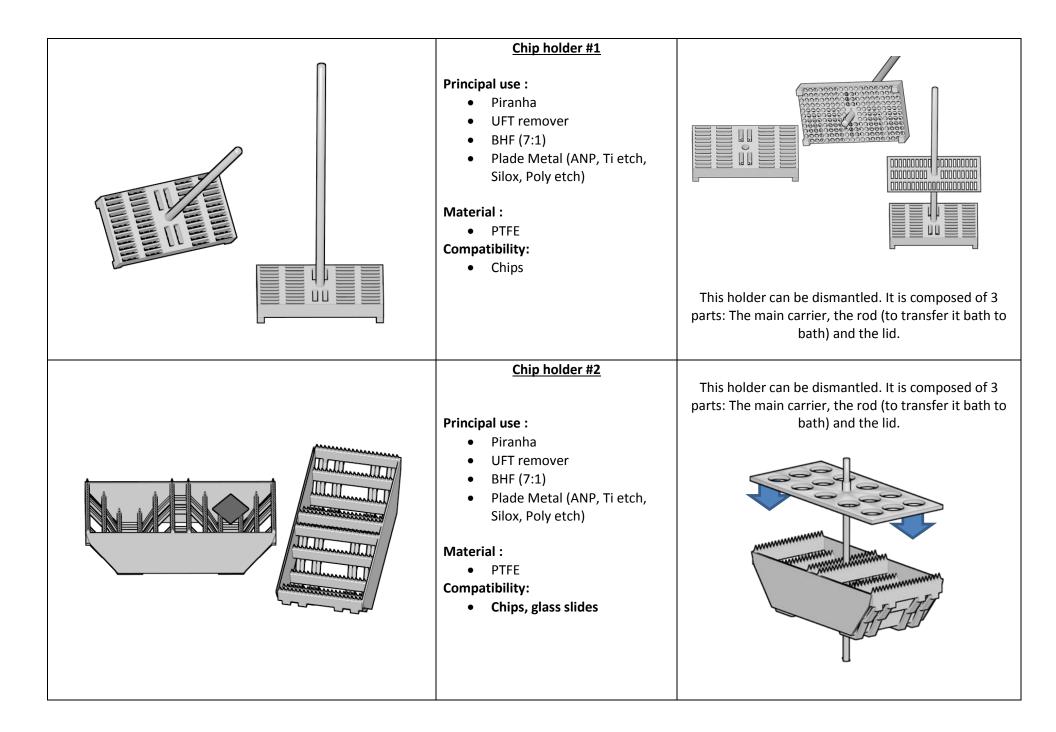
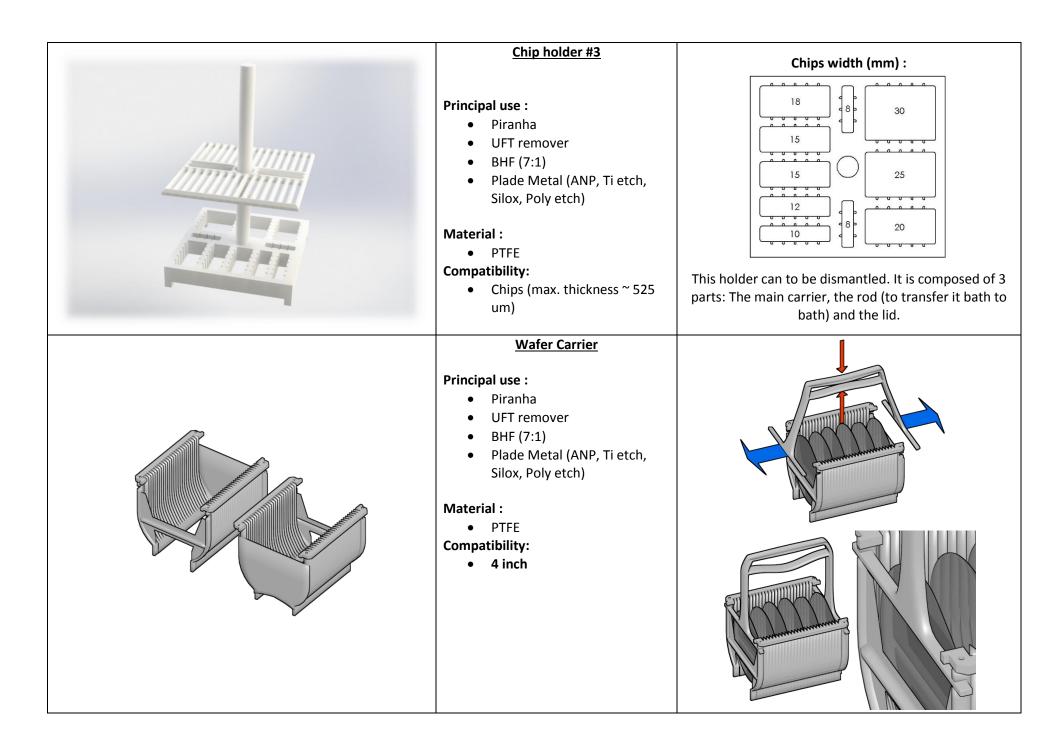
Ζ2		
Holder	Description	Remarks
	Arrow Principal use : • Mask Cleaning using Piranha/Remover Material : • PTFE Compatibility: • 6 inch wafer and mask	Not adapted for 4 inch wafers Not adapted for 4 inch wafers Note that the mask's corner has to fit into the triangle insertion of the biding ring to be correctly held in place.(the biding ring's pin also helps) For the wafer, it is held by placing it in between the arrow's handle and the biding ring fingers.
	Basket Principal use : • Piranha • UFT remover • BHF (7:1) • PLade Metal (ANP, Ti etch, Silox, Poly etch) Material : • PTFE Compatibility: • Chips 1 inch wafer	





Z 12			
Holder	Description	Remarks	
	Wafer Carrier Principal & only use : • PDMS wet bench desiccator Material : • PTFE Compatibility : 4 inch wafers		
Z 14			
Holder	Description PTFE Large breaker Principal use : • Wet etching involving HF Material : • PTFE Compatibility: • Chips only, not adapted for 4 inch wafers	Remarks For long etching It has to be covered using a PTFE watch cover: Image: Constraint of the second se	

